

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
98-P-104D1 (850063.542D1)APPLICATION NO.  
10/827, 409INFORMATION DISCLOSURE STATEMENT  
(Use several sheets if necessary)APPLICANT  
Robert Louis HodgesFILING DATE  
April 19, 2004GROUP ART UNIT  
2822

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>RLH</i>	AA	4,378,627	04/05/83	Jambotkar	28438	571291	
	AB	4,419,810	12/13/83	Riseman	28438	571303	
	AC	4,758,528	07/19/88	Goth et al.	437438	15514	
	AD	5,027,185	06/25/01	Liauh	387257	56413	
	AE	5,434,093	07/18/95	Chau et al.	437438	41300	
	AF	5,597,752	01/28/97	Niwa	437438	44291	
	AG	5,637,516	06/10/97	Müller	438	203	
	AH	5,688,700	11/18/97	Kao et al.	437438	25289	
<i>RLH</i>	AI	5,796,157	08/18/98	Fallico et al.	257	557	
	AJ						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AK					
	AL					
	AM					
	AN					
	AO					

## OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>RLH</i>	AP	IBM Technical Disclosure Bulletin, Vol. 28 #7 pp. 2767-2768, 12/85, 257/346
<i>RLH</i>	AQ	IBM Technical Disclosure Bulletin, Vol. 31 #7 pp. 311-312, 12/88, 257/346
<i>RLH</i>	AR	Wolf et al., "Silicon Processing for the VLSI", Volume 1, Pages 191-194, 1986.

EXAMINER

DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).